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Date:

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TO:

Nicole/M. Barreca Examiner

(703) 872-9311

Art Unit: 1756 /

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Subject Matter:

10/ 038,800 Attorney Doc: 67,200-549

Message:

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Ching-Tien Ma

Group Art Unit: 1756

Serial No.: 10/038,800

Examiner: Nicole M. Barreca

Filed:

Dec. 31, 2001

In Response to Office Action

Dated:

Dec. 12, 2003

For:

Method for Forming Via and Contact Holes with

Deep UV Photoresist

Attorney Docket No.: 67,200-549

Certificate of Facsimile, Transmission

I hereby centify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Patent office via facsimile no. (703) 772-9211 on the date shown below.

Kathy, Dixon

Date: Feb. 17, 2004

REQUEST FOR RECONSIDERATION

Commissioner for Patents Alexandria, VA 22313-1450

Dear Sir:

In response to a final Office Action mailed Dec. 12, 2003, please consider the following remarks.